



2851

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hideki KOMATSUDA

Batch/Confirmation No.: 4482

Allowed: August 19, 2002

Group Art Unit: 2851

Examiner: R. Fuller

Docket No.: 105193.01

Application No.: 09/697,639

Filed: October 27, 2000

For: EXPOSURE APPARATUS AND METHOD OF FABRICATING A MICRO
DEVICE USING THE EXPOSURE APPARATUS

#9
1-28-03
RECEIVED
TECHNOLOGY CENTER 2800
SEP 23 2002

LETTER TO THE OFFICIAL DRAFTSPERSON

Director of the U.S. Patent and Trademark Office
Washington, D.C. 20231

Sir:

Please substitute the attached 27 sheets of formal drawings depicting Figures 1-27 for the corresponding drawings filed with the application. The attached drawings have been corrected pursuant to the Examiner's comment in the Notice of Allowance (Paper No. 7).

Respectfully submitted,

Mario A. Costantino

Registration No. 33,565

MAC/ccs

Date: September 18, 2002

OLIFF & BERRIDGE, PLC
P.O. Box 19928
Alexandria, Virginia 22320
Telephone: (703) 836-6400

**DEPOSIT ACCOUNT USE
AUTHORIZATION**

Please grant any extension
necessary for entry;
Charge any fee due to our
Deposit Account No. 15-0461